Charged Hadron damage investigation of FBK and HPK Low Gain Avalanche Detectors

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Outline

- The High Luminosity (HL) upgrade will increase the luminosity of the Large Hadron Collider (LHC) by a factor of ~10. Increased luminosity causes (1) increased fluence which degrades sensor performance and (2) increased readout complexity because of the pileup.

- Low Gain Avalanche Detectors (LGAD) will be primarily used for fast timing measurement in HL-LHC for the High-Granularity Timing Detector (HGTD) in ATLAS or the Endcap Timing Layer (ETL) of CMS. They are required to operate at a fluence up to 2.5×10^{15} n_{eq}/cm^2 (including a safety factor of 1.5).

- It is required that the HGTD be able to measure the times of arrival of minimum-ionizing particles (MIPs) with an average time resolution of approximately 35 ps per track at the beginning of the operation of the HL-LHC, 70 ps at the end of the operation of the HL-LHC.

- Initial characterization measurements of unirradiated/irradiated LGADs manufactured by Hamamatsu Photonics (HPK) and Fondazione Bruno Kessler (FBK) are underway at UNM.

How do LGADs work?
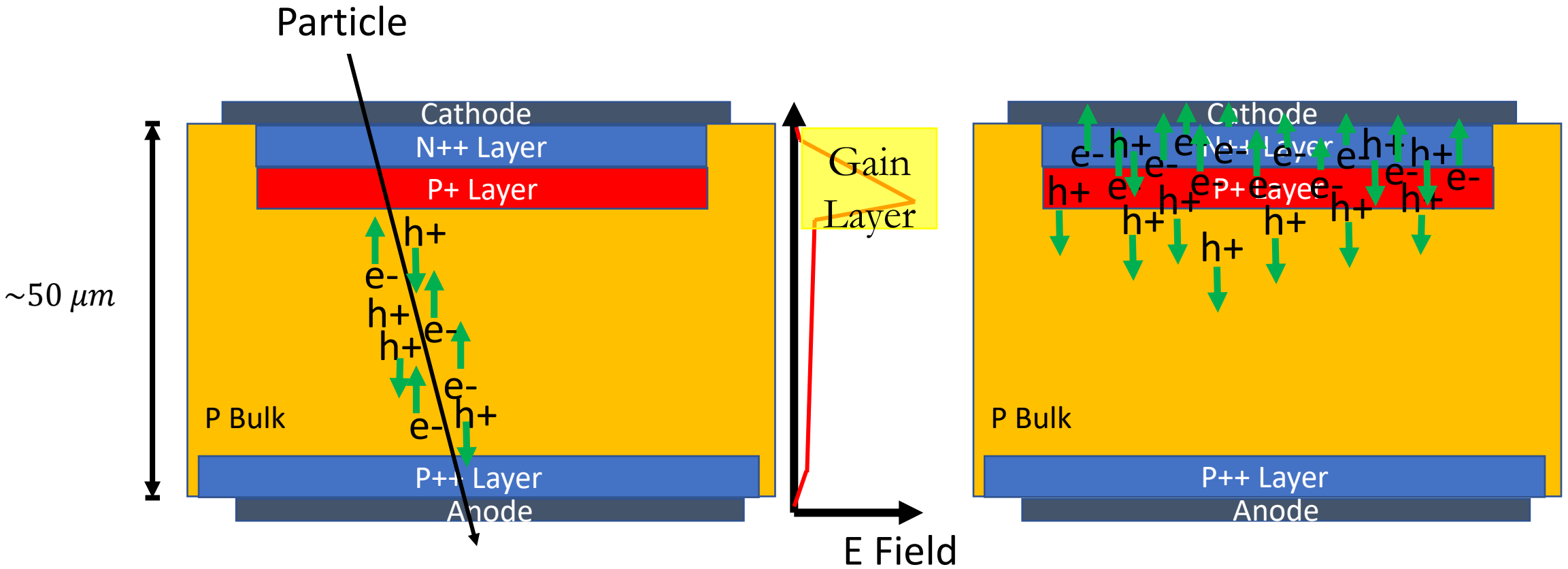
In silicon sensors, charge multiplication happens when charge carriers drift in a region with an electric field (E) greater than about 300 kV/cm. The additional P+ (or gain) layer, when depleted, locally generates an electric field high enough to activate the avalanche process.

Our study includes LGADs manufactured by Hamamatsu Photonics (HPK) and Fondazione Bruno Kessler (FBK).
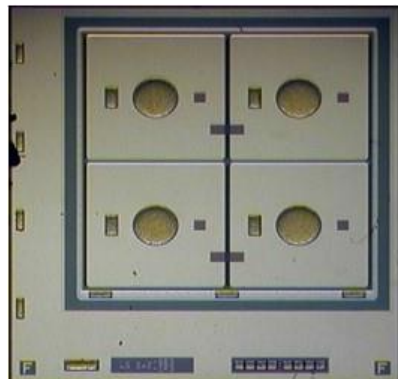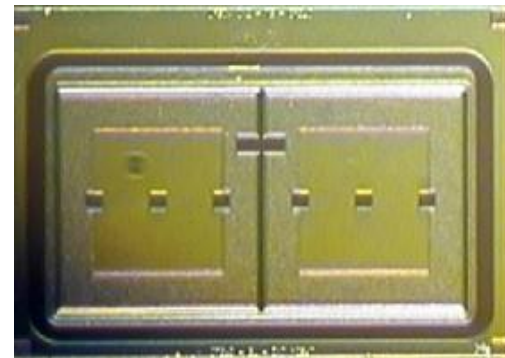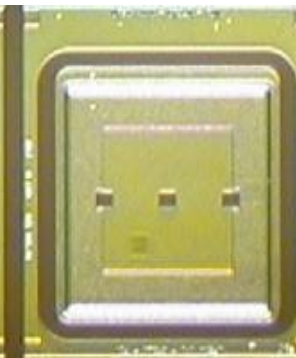
HPK-P2   Quad   Single
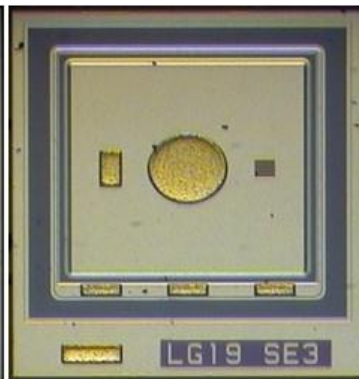
n ++ (electrode) – 1.3 x 1.3 mm^2
p + (gain layer) – 2.2 to 2.5 µm thick
p   (bulk)
p ++ (backside)

50 µm thick active layer
200 µm total thickness
single guard ring
variations with and without under-bump metallization (UBM)
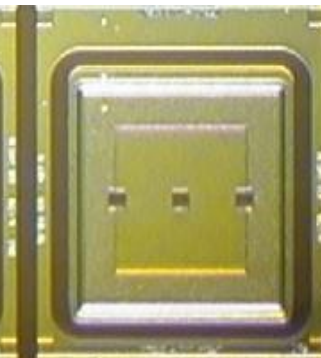epitaxial Si grown on Czochralski substrate

FBK4.0 Double   Single   Single
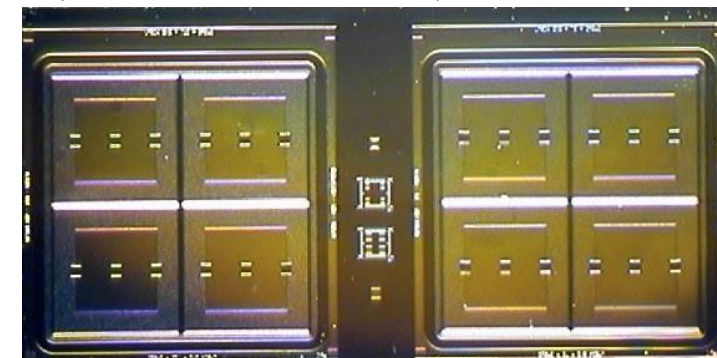

Quad   Quad

n ++ (electrode) – 1.3 x 1.3 mm^2
p + (gain layer): 0.7-2µm thick
p   (bulk)
p ++ (backside)

55 µm thick active layer
multiple guard rings
The depth of the gain implant varies in different samples.

In FBK sensors, carbon co-implantation in the gain layer is used to improve radiation resistance. The carbon dose varies in different samples.

LANSCE/FNAL Proton Irradiation

In 2022, we did two irradiation runs. One at Fermi National Accelerator Laboratory (FNAL) in May, and the other one at Los Alamos Neutron Science Center (LANSCE) in July.

Normally at LANSCE we get 800 MeV protons, but in July 2022 run, we irradiated the FBK samples with 500 MeV protons.
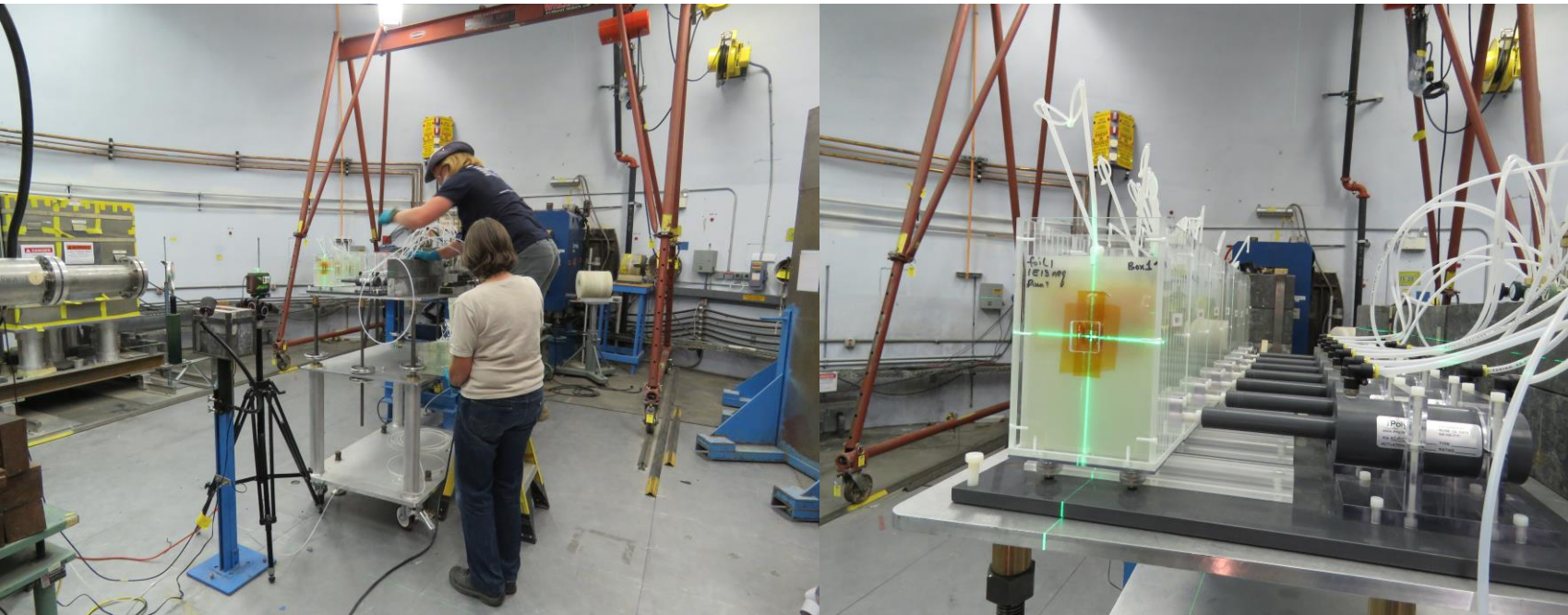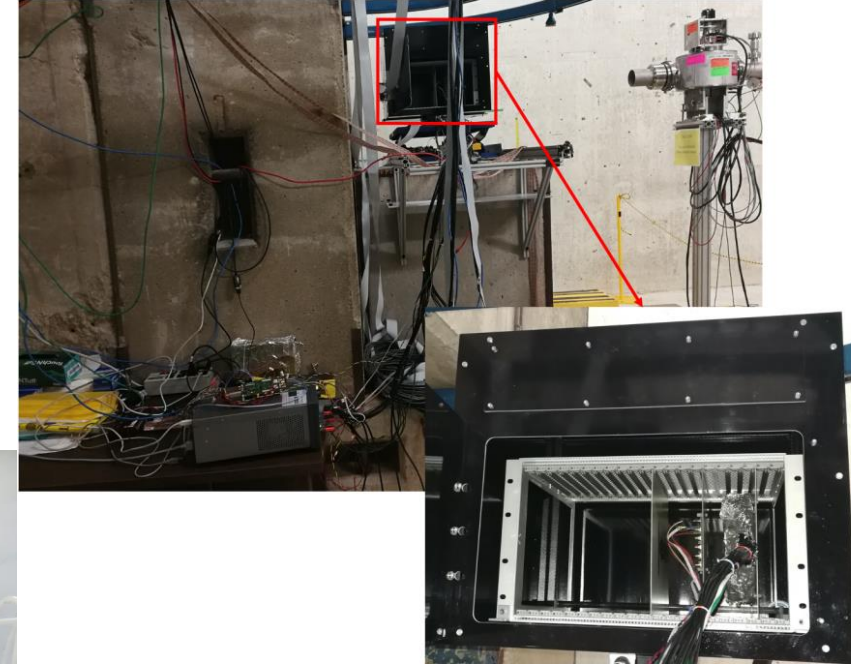
At the FNAL facility, we irradiated HPK samples with 400 MeV protons in May.

Irradiated samples are stored in -25C freezer.

Current vs. Voltage (IV) measurements are used to measure leakage currents, breakdown voltages, and determine the operational ranges.

Keithley 237 source meter provides bias voltage and reads out the leakage current.

Keithley 237
HV Source Measure

Vbias

PC with LabView

Peltier
Constant Current
Power Supply

Dark Box

Vbias

LGAD sensor

Peltier
Thermal Chuck

The thermal chuck can reach -25°C. N2 is used on the sample to prevent condensation.

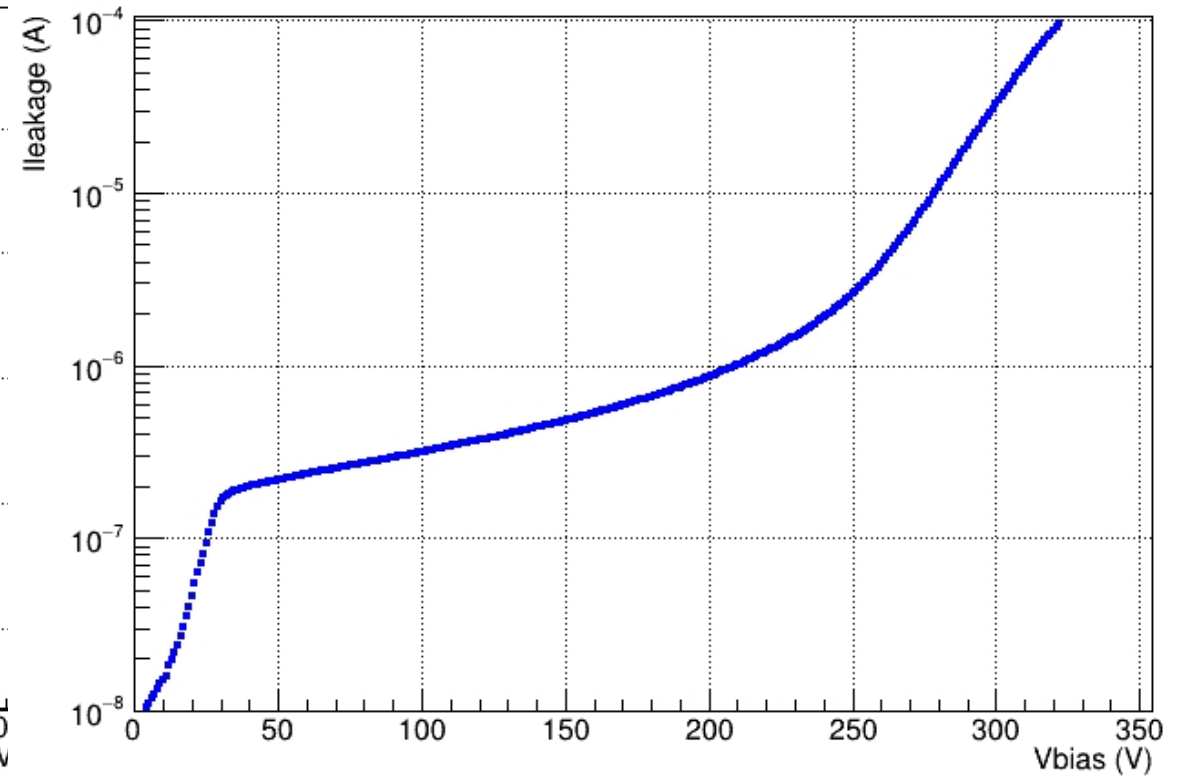# Irradiation increases leakage currents and breakdown voltages of LGADS

IV of W9 D1 1x3(1) R, unirradiated, at 20C

$I_{leakage}$

$V_{breakdown}$
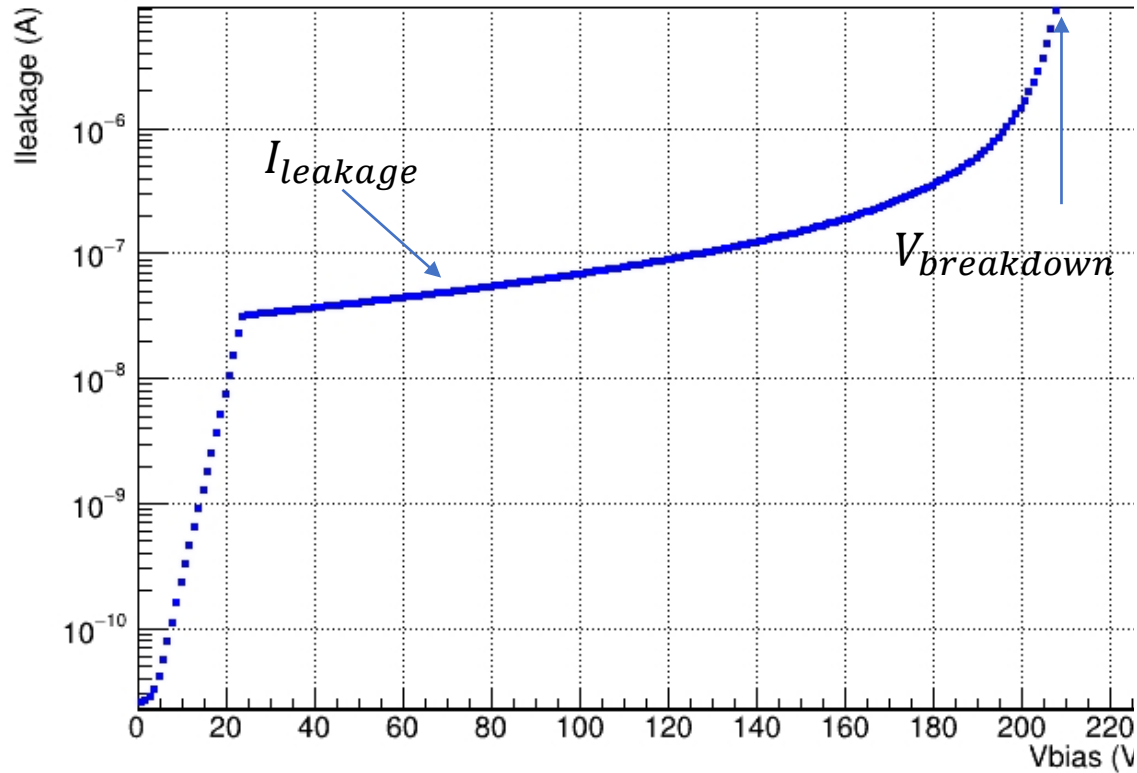
IV of W9 D1 1x3(1) R, irradiated ($2 \times 10^{14} n_{eq}/cm^2$ 500MeV p), at -25C

Capacitance vs. Voltage (CV) Measurements are used to measure the depletion voltage

Keithley 237
HV Source
Measure

Vbias

HP4284A
LCR Meter

Bias
Isolation
Box

Vbias

LGAD sensor

Dark Box

Peltier
Thermal Chuck

PC with LabView
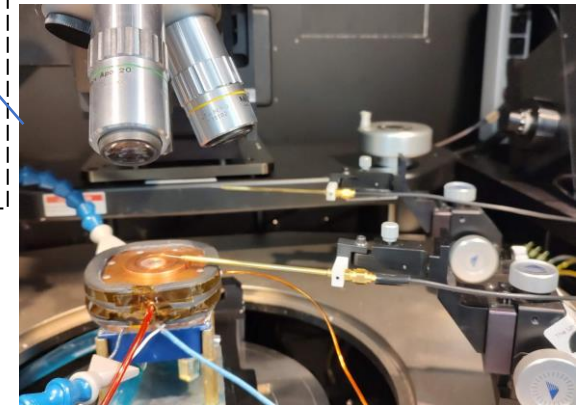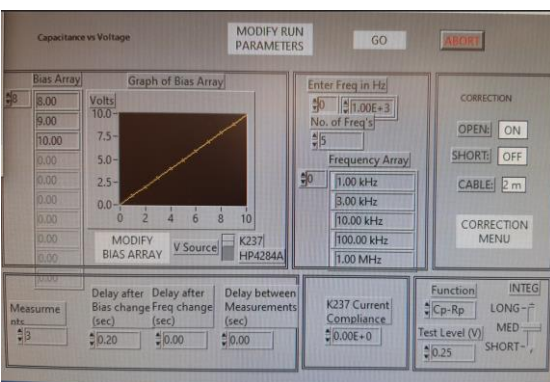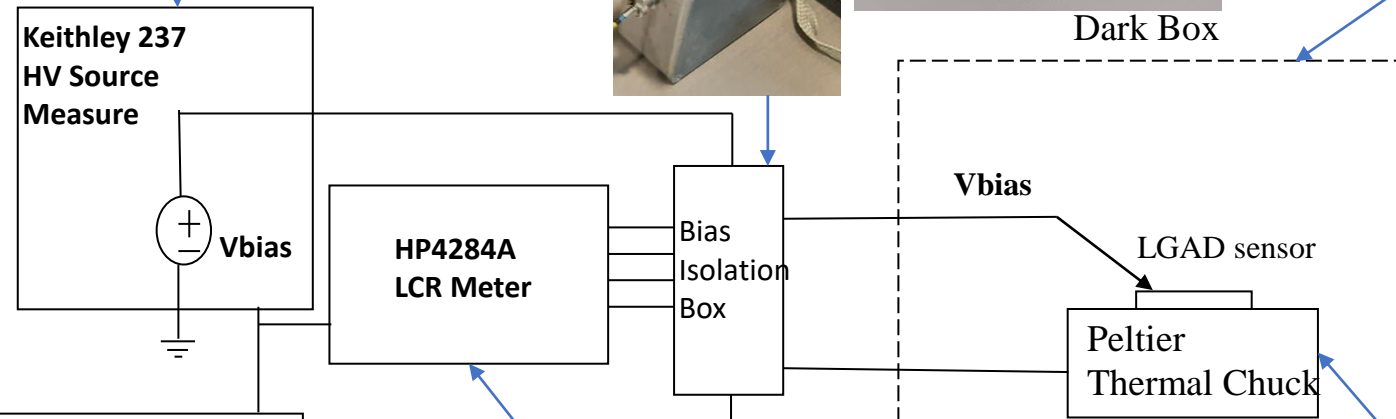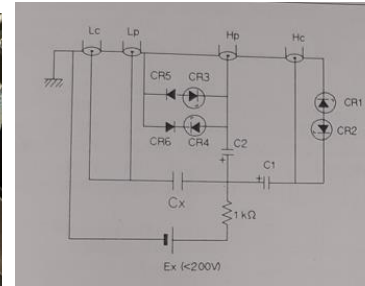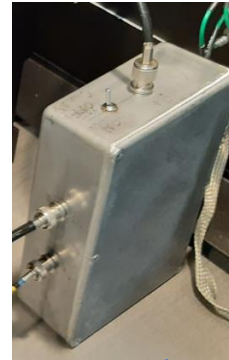
CV Measurements are used to extract the gain layer depletion voltage V_{gl} and full depletion voltage V_{fd}

W25 Pre-Irradiated 1E14 A

CV Data, 1 MHz
Linear Fit

intercept = 0.0647051
slope = 3.159e-005

Vfd = 61.2 V

intercept = -0.502555
slope = 0.0092977

intercept = 0.000148365
slope = 4.9294e-006

Vgl = 54.1 V
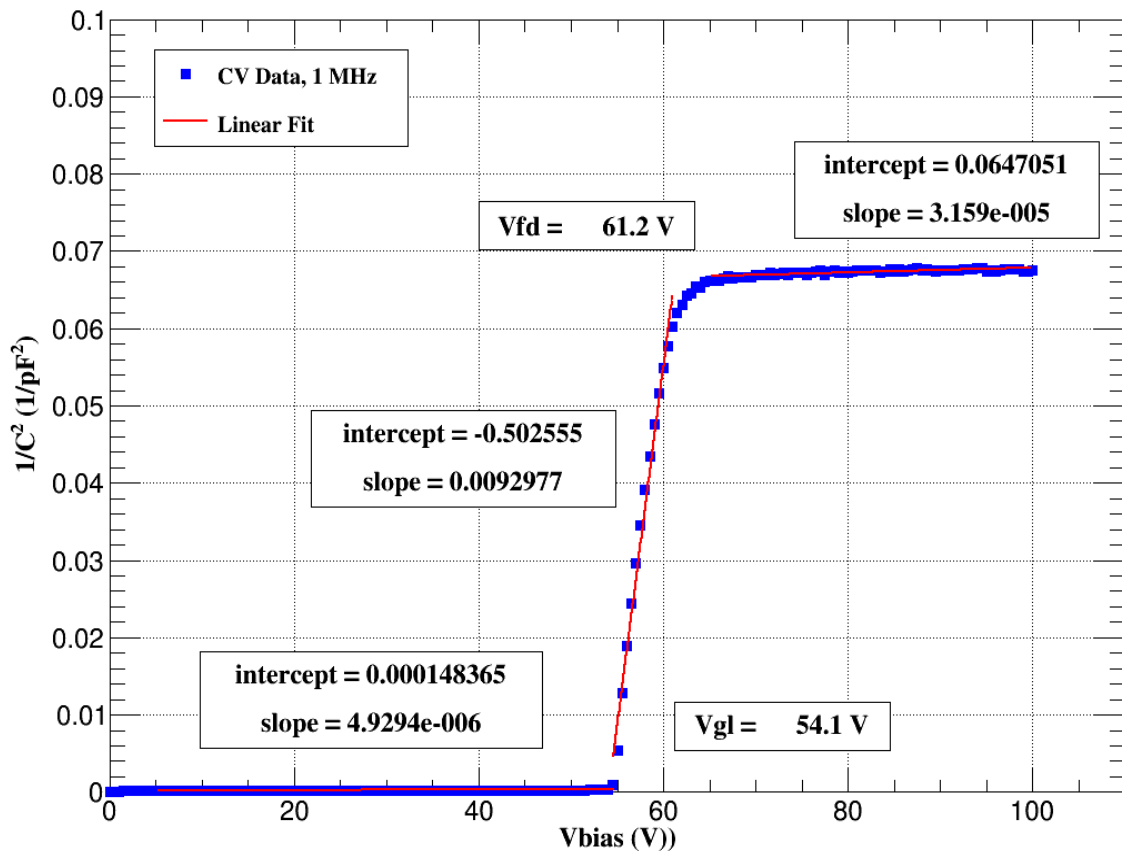
The depletion voltage of the gain layer depends on the dopant concentration, which is impacted by radiation fluence

Dopant Concentration

Electron charge

Gain Layer depth

Gain layer depletion voltage

$$V_{gl} = \frac{qN_Aw^2}{2\epsilon}(1+2\frac{d}{w})$$

Permittivity of Silicon

Gain Layer Thickness

β-source setup is used to study the timing performance of LGADs

Thermal
Chamber at -30C

Sr
90

Beta
Collimator

REF

UCSC Board

1st Stage Amplifier

DUT

UCSC Board

Particulars
AM-01B
(2nd Stage Amplifier)
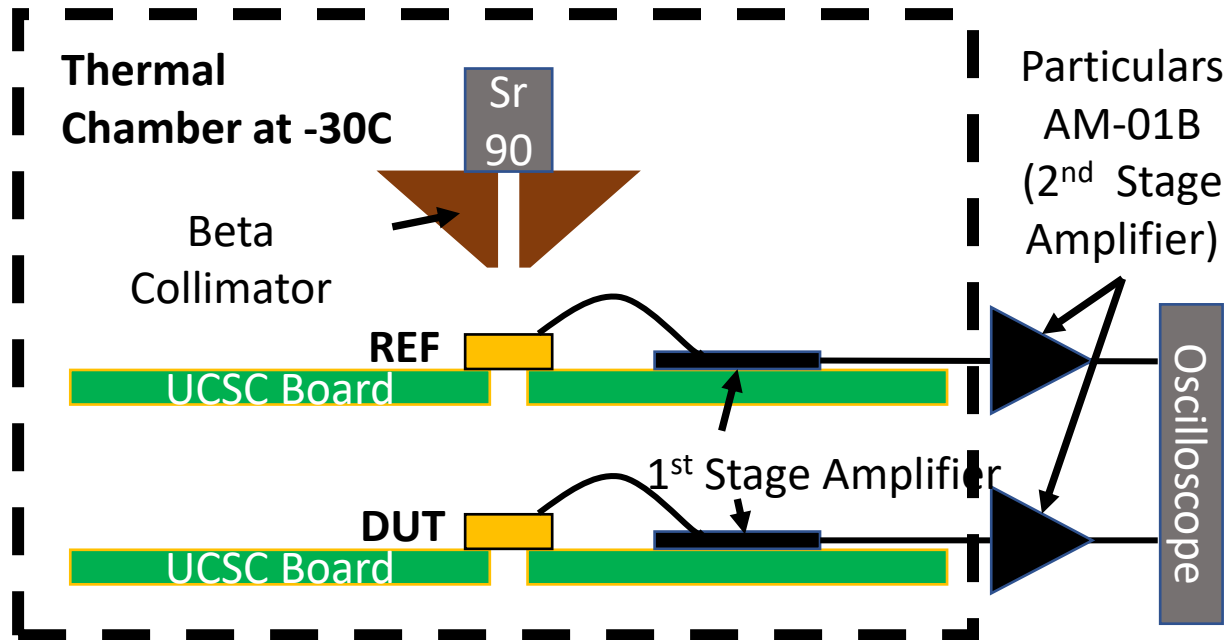
Oscilloscope

- LGADs are mounted on the single channel readout board developed by UCSC.

- Tektronix DPO 7254 Oscilloscope with 2.5GHz bandwidth, 40GS/s sampling rate is used.

- Shortest cables are used to connect to the oscilloscope for best signal-to-noise performance.

- Time resolution requirement: 35 ps (start) and 70 ps (end of life).

# 3 methods were used to calculate the resolution

- Only signals triggering both REF and DUT channels are collected.
- The resolution is calculated from the temporal deviation of ~2000 events.
- Constant Fraction Discriminator (CFD) method of 25%, 2-point linear fitting, and 4-point linear fitting were used, the differences are within a few percent.
- Equation $\sigma_{tot}^2 = \sigma_{REF}^2 + \sigma_{DUT}^2$ is used to calculate the resolution.

CFD of 25%

2-points linear fitting

4-points linear fitting
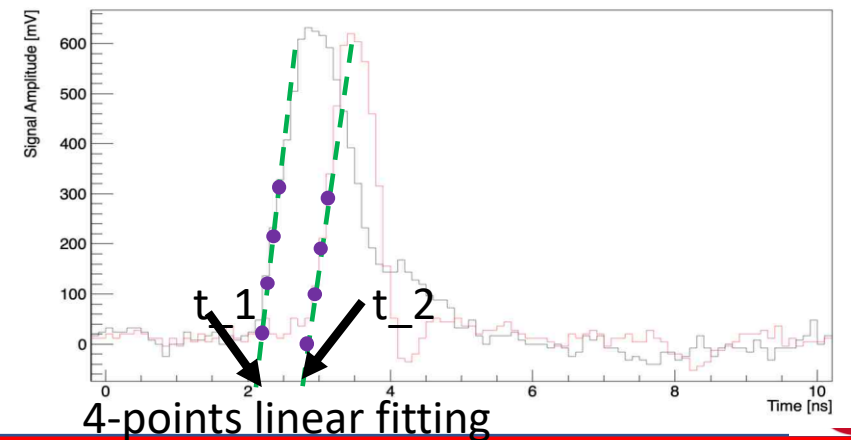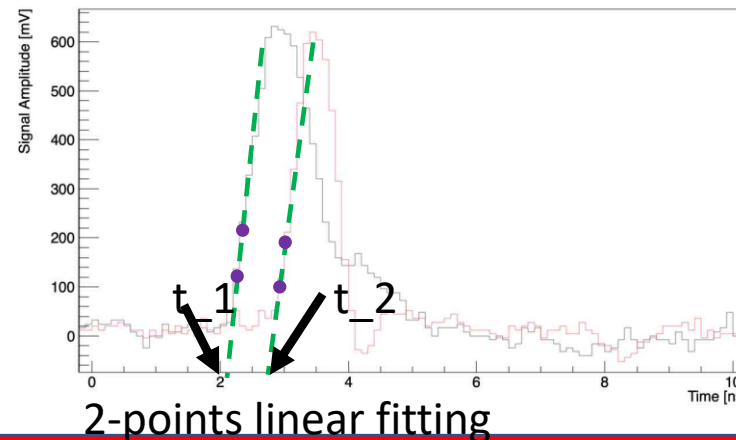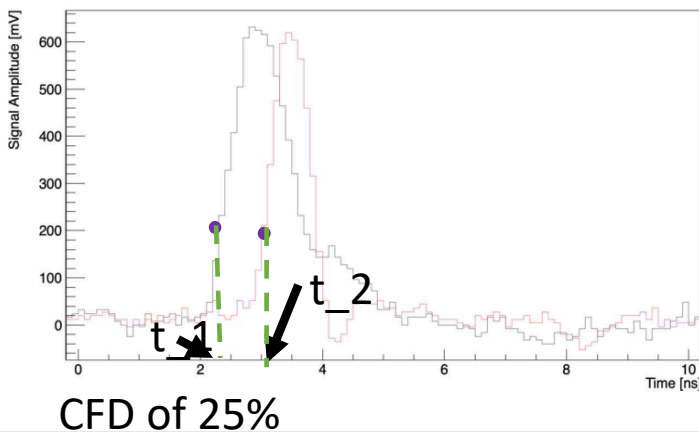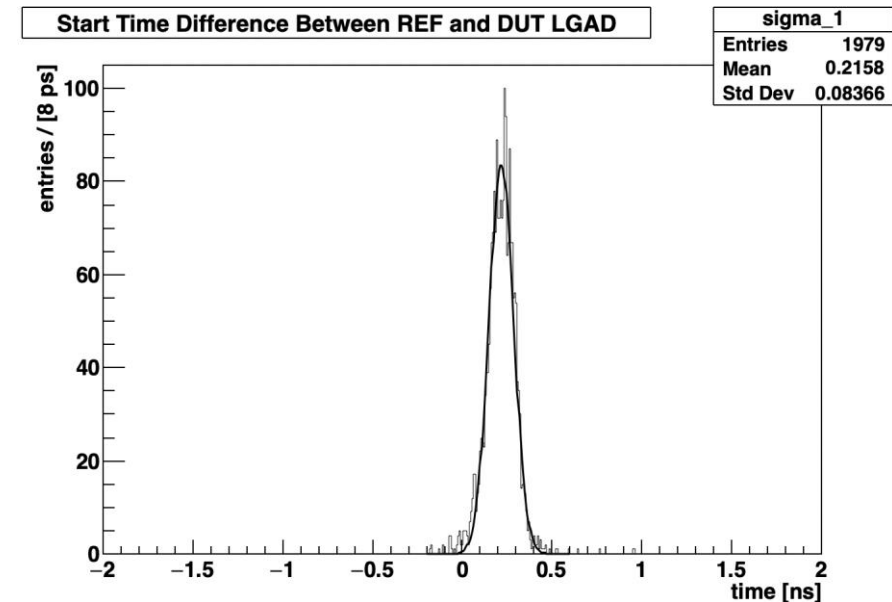
Two identical HPK sensors (unirradiated) are used as the references for timing measurements

When measuring the timing of two identical sensors, $\sigma_{REF} = \sigma_{DUT}$ so a single measurement will give you the temporal resolution of both sensors.

Either of the unirradiated sensors can be used as the reference for the timing measurements for the irradiated sensors.

W43-L1P7 and W43-L1P8 Timing Measurement

Temperature: 243 K
REF: HPK-2 W43 L1P8
DUT: HPK-3 W43 L1P7
Both LGADs biased at same voltage for each measurement
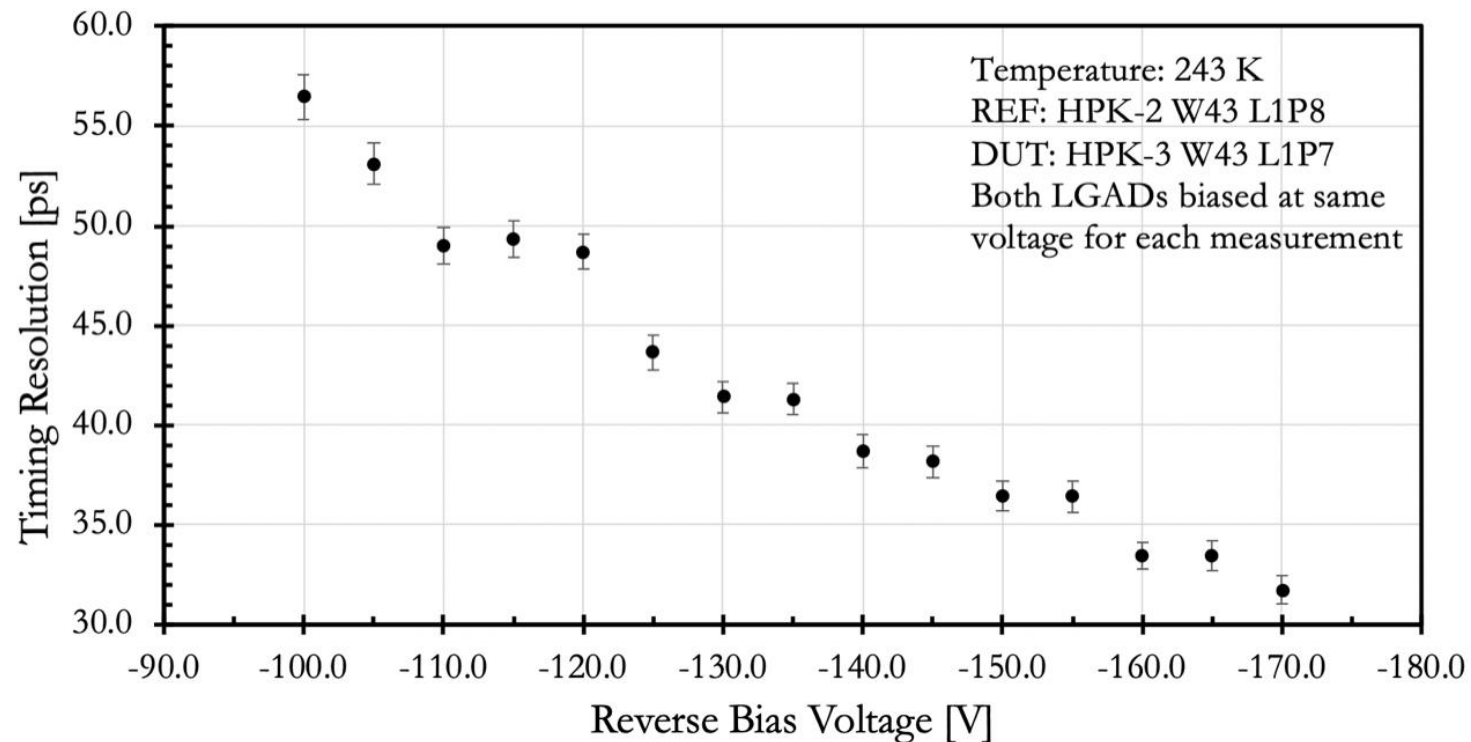
Study of the effect of high temperature annealing upon LGAD capacitance and current

To match the LGAD community's standard procedure, irradiated samples were annealed at 60^oC for 80 minutes. However, pre-annealing measurements were also performed.

IV of W9 D1 1x3(1) R, irradiated ($2 \times 10^{14} n_{eq}/cm^2$ 500MeV p), at 20^0C

- post-annealing, at 20^oC
- pre-annealing, at 20^oC

CV of W9 D1 1x3(1) R, irradiated ($2 \times 10^{14} n_{eq}/cm^2$ 500MeV p), 20^oC, 10kHz test freq

- post-annealing, at 20^oC
- pre-annealing, at 20^oC
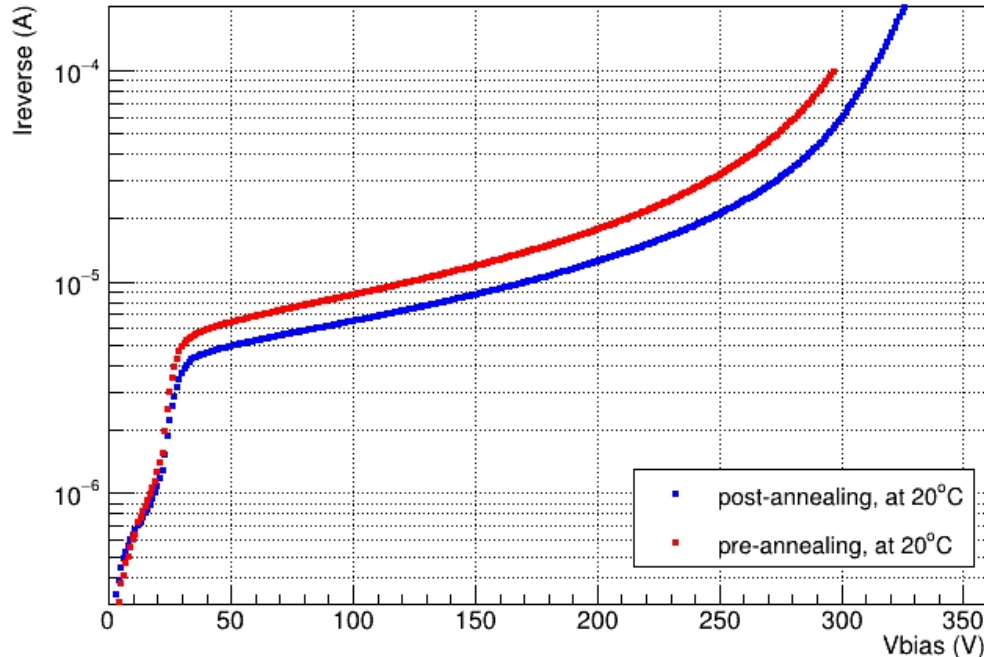
After annealing, leakage current reduced by ~1/3, Breakdown voltage increased ~20V.
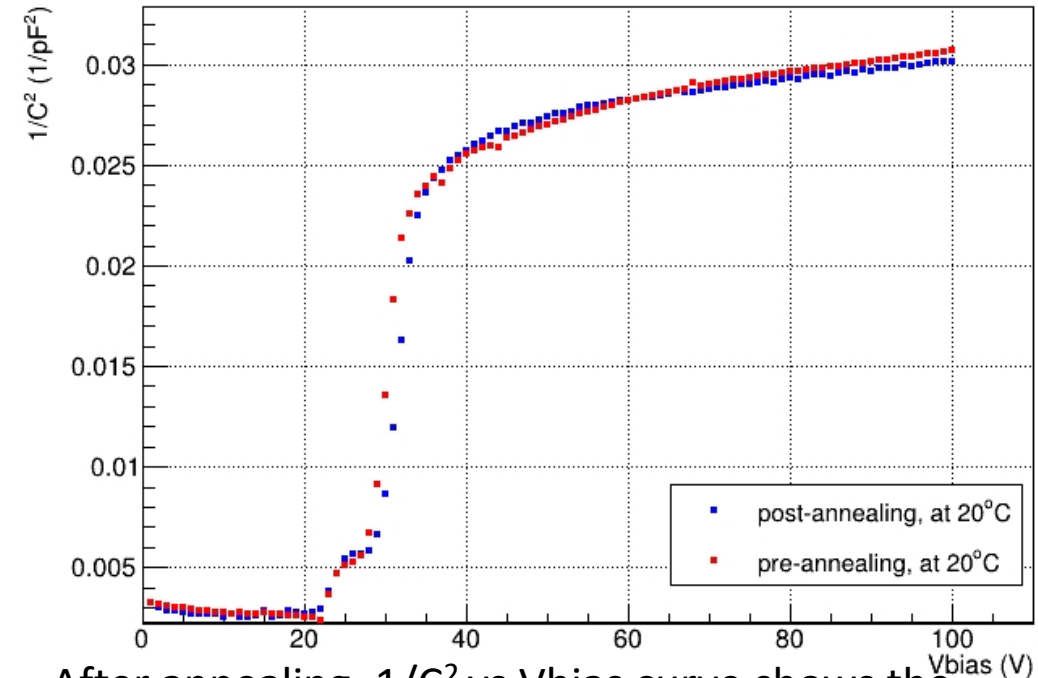
After annealing, $1/C^2$ vs Vbias curve shows the concentration has a mild change. Understanding CV characteristics of irradiated sensors is our next goal...

Preliminary timing resolution measurement is ongoing...

FBK W9 (preliminary result)
Proton Irradiated 2E14 neq/cm²
Annealed at 60 C for 80 min
T = -30 C

54.9 ps < 70 ps
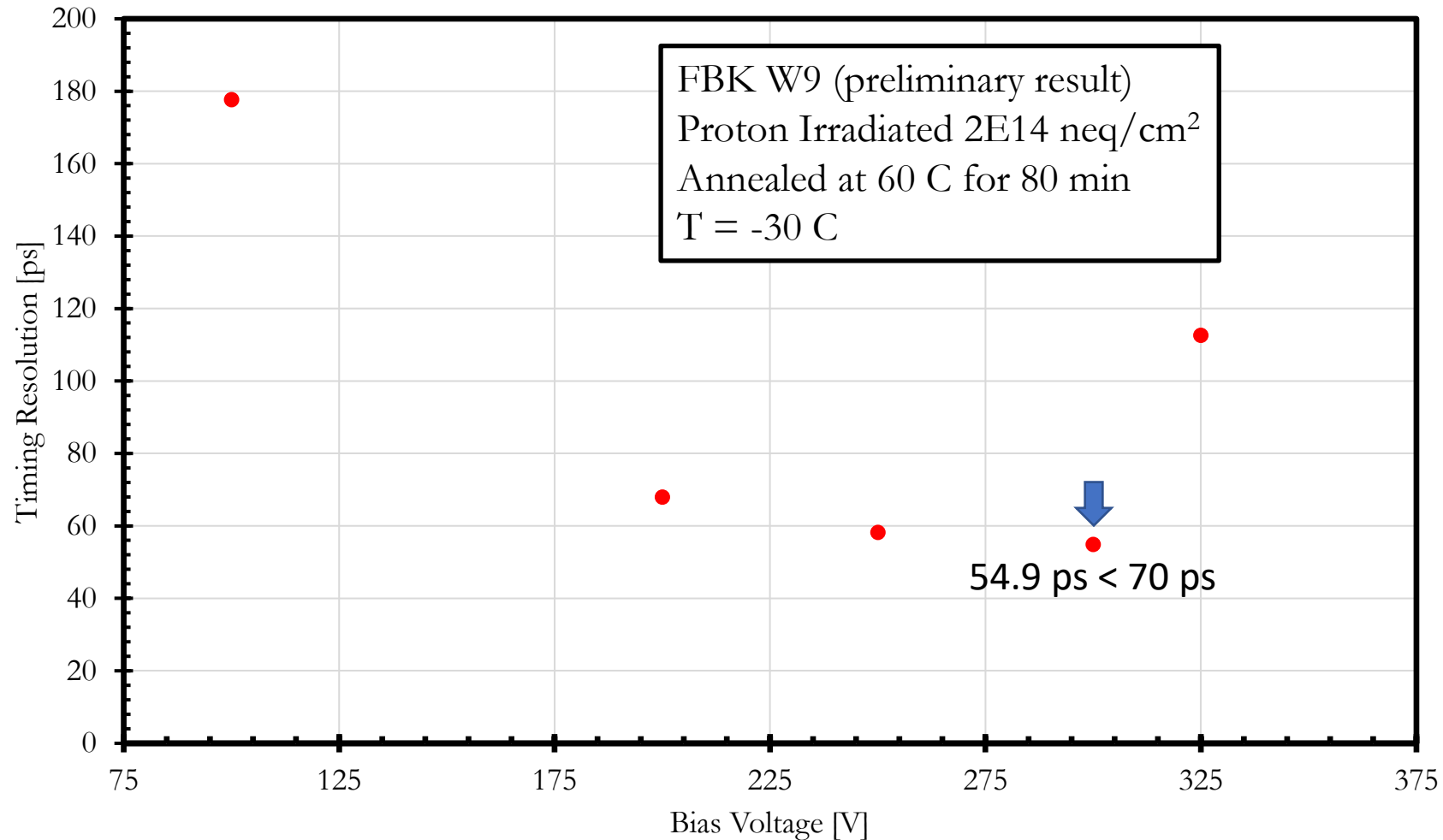
Summary

- We have set up the instruments for IV, CV, and timing measurement.

- Two irradiation runs were performed at FNAL and LANSCE in 2022.

- Pre-irradiation measurements were performed.

- Working on post-irradiation measurements (just started).

- With the LGADs irradiated at different fluences, one of our goals is to estimate acceptor removal coefficients using $V_{gl} = \frac{qN_A w^2}{2\epsilon}(1+2\frac{d}{w})$

- There are still many samples to measure and study...

Thank You!

Backup Slides

From Technical Design Report:
A High-Granularity Timing Detector for the
ATLAS Phase-II Upgrade p88
ATLAS-TDR-031.pdf

Technology	Silicon Low Gain Avalanche Detector (LGAD)
Time resolution	$\approx 35\,\text{ps}$ (start); $\approx 70\,\text{ps}$ (end of lifetime)
Time resolution uniformity	No requirement
Min. gain	20 (start); 8 (end of lifetime)
Min. charge	4 fC
Min. hit efficiency	95%
Granularity	$1.3\,\text{mm} \times 1.3\,\text{mm}$
Max. inter-pad gap	$100\,\mu\text{m}$
Max. physical thickness	$300\,\mu\text{m}$
Active thickness	$50\,\mu\text{m}$
Active size	$39\,\text{mm} \times 19.5\,\text{mm}$ (30×15 pads)
Max. inactive edge	$500\,\mu\text{m}$
Radiation tolerance	$2.5 \times 10^{15}\,\text{n}_{\text{eq}}\,\text{cm}^{-2}$, 1.5 MGy
Max. operation temperature on-sensor	$-30\,^{\circ}\text{C}$
Max. leakage current per pad	$5\,\mu\text{A}$
Max. bias voltage	800 V
Max. power density	$100\,\text{mW/cm}^2$

Table 5.1: Sensor parameters and requirements.

From Technical Design Report:
A High-Granularity Timing Detector for the
ATLAS Phase-II Upgrade p110
ATLAS-TDR-031.pdf

Annealing

Most of the measurements with irradiated sensors were done after annealing for 80 min at 60 °C, which roughly simulates the operational conditions in one year of LHC operation since higher temperature accelerates the annealing (the Arrhenius factor between 60 °C and −30 °C is more than 1×10^6, 80 min simulates hundreds of years at −30 °C, and tens of days at room temperature).

The actual design includes p-stops to limit inter-pad current, guard rings, and junction termination extensions which mitigate breakdown voltage, and other features.
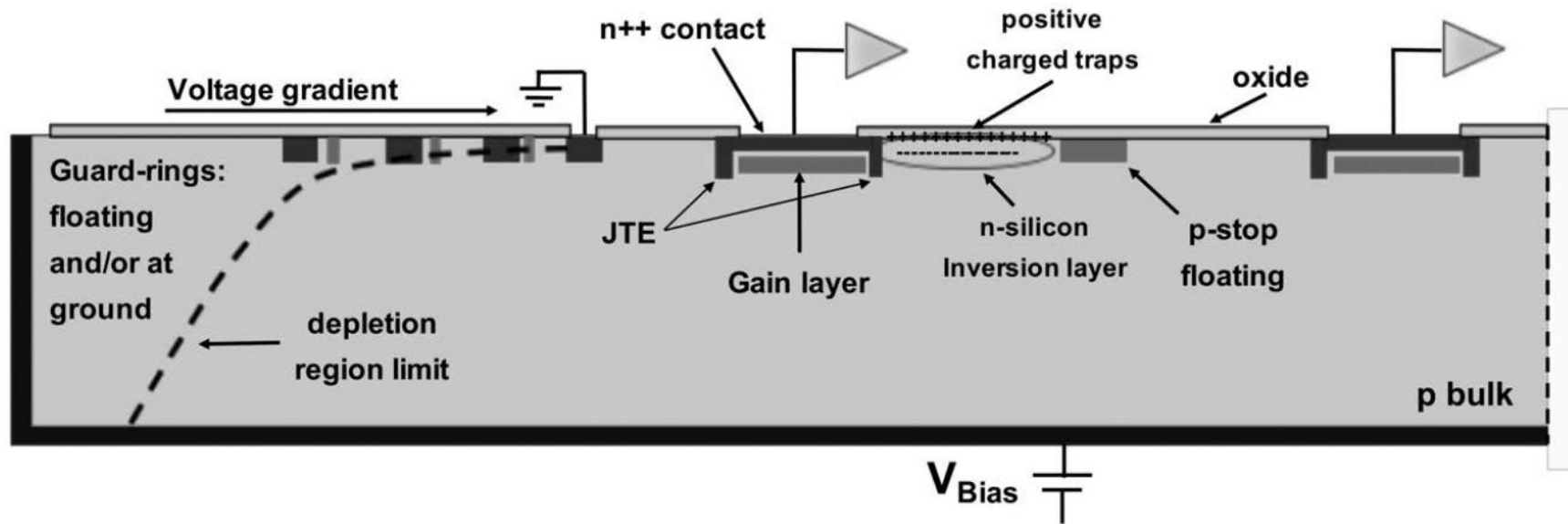

Figure 2.21 Cross cut of a multi-pads UFSD (not to scale) with a schematic view of the building blocks of the device. From the device physical edge: guard-rings, pad with JTEs, inter-pad region with *p*-stop.

An Introduction to Ultra-Fast Silicon Detectors p33

An Introduction to Ultra-Fast Silicon Detectors p84

Using the information provided by the $C(V)$ measurements, it is possible to:

1. extract the gain layer implant profile (amplitude, width, depth) by computing the active doping concentration $N_A(d)$ as a function of depth d. This is obtained by first calculating d from the value of C with
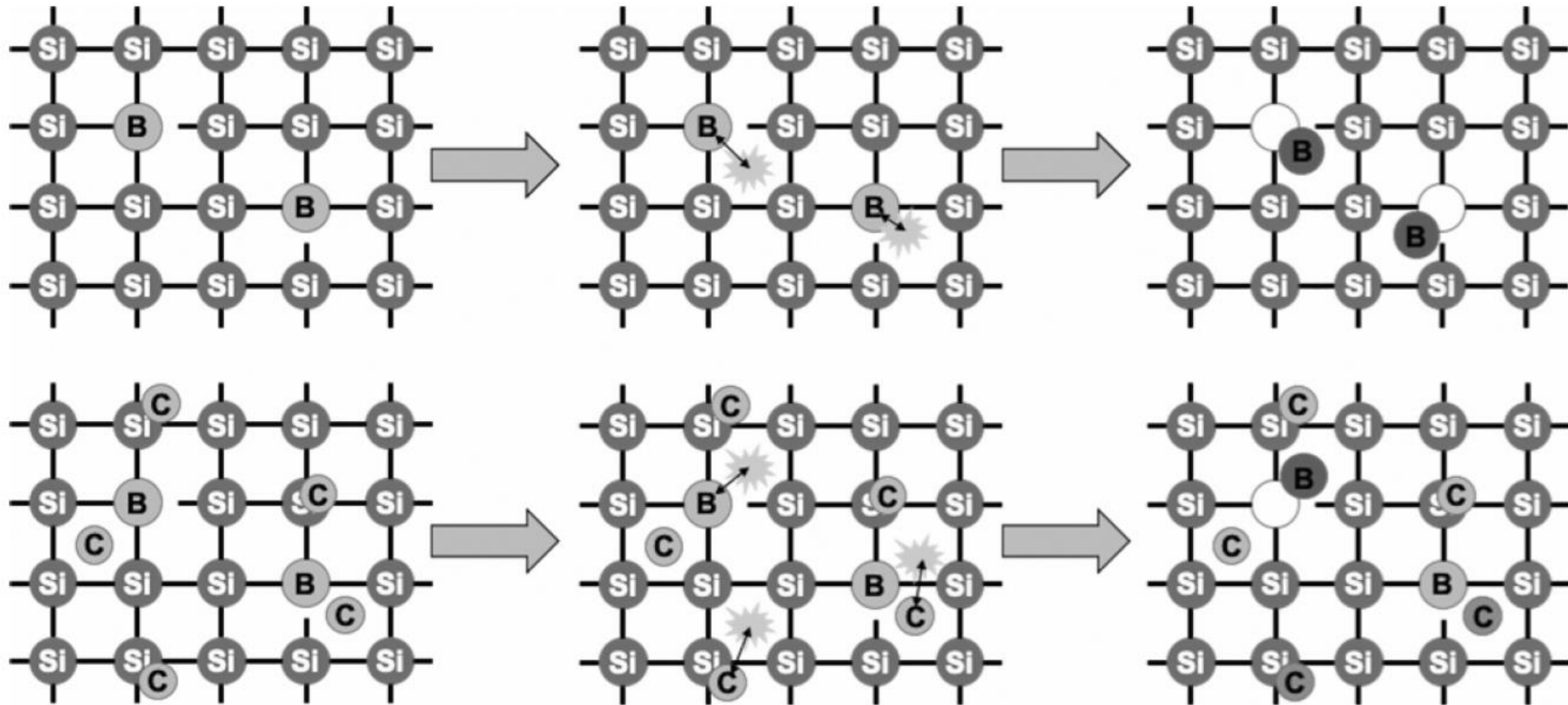
$$d = \frac{\varepsilon_{Si}A}{C} \tag{4.4}$$

and then the doping density at that depth d with:

$$N_A = \frac{2}{\varepsilon_{Si}qA^2 \frac{\partial 1/C^2}{\partial V}}, \tag{4.5}$$

An Introduction to Ultra-Fast Silicon Detectors p38

An Introduction to Ultra-Fast Silicon Detectors p16

Figure 2.3 Schematic cross cut of a UFSD with broad (*left*), shallow (*middle*), and deep (*right*) gain implants and their respective electric field profiles.

IV of W9 D1 1x3(1) R LGAD & PIN, unirradiated, at 20C